

ACCEPTE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Assistant Commissioner for Patents, Washington, D.C. 20231, on 2/5/99



- 1 -

Docket: 0756-1799

5/13/99
2/24/99
PC

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT Application of)

Mitsunori SAKAMA)

Serial No. 09/070,908)

Filed: May 4, 1998)

For: FILM FORMING METHOD AND)
FILM FORMING APPARATUS)

RECEIVED

Feb 23 1999

GROUP 1700

) Art Unit: 1762

) Examiner: M. Padgett

) Date: February 5, 1999

AMENDMENT

Honorable Assistant Commissioner for Patents

Washington, D.C. 20231

Sir:

In response to the Office Action of November 5, 1998, please amend the subject application as follows:

IN THE CLAIMS:

Please cancel claims 1-15 and 20-22 and add new claims 23-50 as follows:

23. A film forming method comprising:
a first step of supplying a hydrogen gas into a chamber;

02/17/1999 MNARML 00000960 09070908

01 FC:102
02 FC:103

156.00 DP
108.00 DP